

Notice of References Cited

Application/Control No.

10/501,440

Applicant(s)/Patent Under
Reexamination
MPHOLO ET AL.

Examiner

ALEX NOGUEROLA

Art Unit

1753

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,113,768	09-2000	Fuhr et al.	204/643
	B	US-4,390,403	06-1983	Batchelder, J. Samuel	204/547
	C	US-			
	D	US-			
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	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	EP 0957576 A2	11-1999	EP	Tautsumi et al.	H03H 9/05
	O	WO 9734689 a1	09-1997	WO	Pethig et al.	B01J 19/00
	P					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Studer et al. ("Fabrication of micro fluidic devices for AC electrokinetic fluid pumping," Microelectronic Engineering 61-62 (2002) 915-920)
	V	Schnelle et al. (Adhesion Inhibited Surfaces. Coated and Uncoated Interdigitated Electrode Arrays in the Micrometer and Submicrometer Range," Langmuir 1996, 12, 801-809)
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.